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Characterization of angularly resolved EUV emission from 2-\(\mu\)m-wavelength laser-driven Sn plasmas using preformed liquid disk targets

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Abstract

The emission properties of tin plasmas, produced by the irradiation of preformed liquid tin targets by several-ns-long 2 \(\mu\)m-wavelength laser pulses, are studied in the extreme ultraviolet (EUV) regime. In a two-pulse scheme, a pre-pulse laser is first used to deform tin microdroplets into thin, extended disks before the main (2 \(\mu\)m) pulse creates the EUV-emitting plasma. Irradiating 30- to 300 \(\mu\)m-diameter targets with 2 \(\mu\)m laser pulses, we find that the efficiency in creating EUV light around 13.5 nm follows the fraction of laser light that overlaps with the target. Next, the effects of a change in 2 \(\mu\)m drive laser intensity (0.6–1.8 \times 10^{11} \text{ W cm}^{-2}) and pulse duration (3.7–7.4 ns) are studied. It is found that the angular dependence of the emission of light within a 2\% bandwidth around 13.5 nm and within the backward 2\(\pi\) hemisphere around the incoming laser beam is almost independent of intensity and duration of the 2 \(\mu\)m drive laser. With increasing target diameter, the emission in this 2\% bandwidth becomes increasingly anisotropic, with a greater fraction of light being emitted into the hemisphere of the incoming laser beam. For direct comparison, a similar set of experiments is performed with a 1 \(\mu\)m-wavelength drive laser. Emission spectra, recorded in a 5.5–25.5 nm wavelength range, show significant self-absorption of light around 13.5 nm in the 1 \(\mu\)m case, while in the 2 \(\mu\)m case only an opacity-related broadening of the spectral feature at 13.5 nm is observed. This work demonstrates the enhanced capabilities and performance of 2 \(\mu\)m-driven plasmas produced from disk targets when compared to 1 \(\mu\)m-driven plasmas, providing strong motivation for the use of 2 \(\mu\)m lasers as drive lasers in future high-power sources of EUV light.

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(Some figures may appear in colour only in the online journal)

1. Introduction

Laser-produced plasmas containing highly charged tin ions are the light source of choice for state-of-the-art extreme ultraviolet (EUV) lithography [1–11]. Tin is used because no less than five of its charge states (Sn$^{10+}$−Sn$^{14+}$) strongly emit, with large amounts of atomic transitions clustered in so-called unresolved transition arrays (UTAs) [12], in a narrow band around 13.5 nm [13–23] that matches the peak reflectivity of available multilayer optics [24, 25]. These emission characteristics enable a high conversion efficiency (CE) of drive laser light into in-band radiation into the backward hemisphere towards the laser origin, with in-band radiation defined as radiation in a 2% bandwidth centered at 13.5 nm. The tin ions are bred in a hot (∼30–60 eV) and dense (10$^{19}$–10$^{21}$ e− cm$^{-3}$) plasma. Starting from mass-limited tin-microdroplets, a low intensity pre-pulse (PP) deforms the droplets into a shape better suited for interaction with a second high-intensity main pulse (MP), used to create the EUV-emitting plasma. This two-step process is crucial for reaching source efficiencies and power levels that allow for the industrial utilization of EUV lithography [26–29]. Currently, 10.6 µm-wavelength CO$_2$ gas lasers are used to drive the plasma, achieving CE values of up to 6% [2]. Recent simulation studies however have drawn significant attention to the use of a 2 µm main pulse, a wavelength at which high-power solid-state lasers may soon become available [30]. These simulation results show that CE values of the 2 µm driven plasmas may be on par with the ones of 10 µm driven plasmas, at which point the expected higher wall-plug efficiency [31] of near- to mid-infrared solid state over gas lasers may make for an overall more efficient EUV source using the shorter 2 µm wavelength. Shorter drive laser wavelengths have the additional advantage of a higher coupling efficiency of laser light with the tin plasma. The scaling of the here relevant inverse bremsstrahlung absorption coefficient $k_L \propto \lambda^2 n_e^2$, with wavelength $\lambda$ and electron density $n_e$ indicates that shorter wavelength light is absorbed less efficiently at equal plasma density but because of the higher critical electron density ($n_c \propto \lambda^{-2}$), the shorter wavelength laser light can penetrate into denser plasma regions leading to an overall increased absorption of the laser light, with the absorption taking place in regions of higher emitter and absorber density. This may benefit the obtainable source brightness but an associated increase in optical depth [32, 33] leads to increased broadening of spectral features outside the in-band region relevant for EUV lithography. This broadening may limit the obtainable CE. Limitations on the spectral performance of EUV sources imposed by optical depth have been studied in detail for plasmas driven by 1 µm Nd:YAG lasers [32, 34, 35]. A 2 µm wavelength, between the widely investigated 1 and 10 µm, is an interesting candidate providing intermediate plasma densities and hence optical depth. In addition to 2 µm systems based on difference frequency generation [33, 36, 37], high-power Big Aperture Thulium (BAT) laser systems, operating at 1.9 µm wavelength, are currently under development [38, 39].

Despite its importance for EUV lithography, literature on the production of in-band radiation from mass-limited, prepulse deformed targets remains rather scarce, with the majority of studies to-date focusing on $\lambda = 10$ µm main pulses (see, e.g. [29, 40–42]). A broad body of literature has investigated experimentally the emission from undeformed liquid tin droplet targets [9, 34, 43, 44], coated spheres [45] or solid-planar targets [46–49] using 1 µm solid-state lasers. First results from experiments using 2 µm laser light driving plasma from solid-planar tin targets [37] as well as from undeformed liquid tin droplet targets [33] have recently been presented. Both works demonstrate the potential of the 2 µm drive wavelength, showing a doubling of the obtainable CE over the 1 µm driver, to a 3% level for the solid-planar tin target. At this 3% level the overall conversion efficiency of wall plug power to in-band EUV may be at par with the current CO$_2$-driven industrial solutions. Literature on industrially-relevant mass-limited deformed targets interacting with either 1- or 2 µm main pulse beams at high CE is however not yet available.

In this publication, EUV light production from mass-limited tin targets, suitably shaped by a 1 µm laser pre-pulse, is investigated using 1- and 2 µm main pulse laser systems to drive the plasma. First, plasma produced with a 2 µm laser beam is investigated for three different laser intensities and three laser pulse durations. For each laser parameter set a wide range of target diameters (30–300 µm) is investigated and the resulting angular distribution of in-band emission, the efficiency of converting laser light into in-band EUV radiation and overall EUV radiation, as well as the spectral performance of the plasma, are characterized. Secondly, plasmas generated by 1- and 2 µm drive laser light are characterized and compared.

2. Method

In the experiments, micrometer-sized liquid tin droplets are first irradiated with a relatively low intensity (∼10$^6$ W cm$^{-2}$), 1 µm wavelength PP (see figure 1(a)) from an Nd:YAG laser. The PP propels the droplets and deforms them into extended, disk-like targets of diameter $d_T$ [50–53] with typical radial expansion speeds of ∼90 m s$^{-1}$. The target diameter is precisely controlled via the time delay between pre- and main pulse, which ranges 0–3 µs. In all measurements concerning 2 µm main pulses, the spatial beam profile of this PP laser is Gaussian with a size of 120 µm at full width at
The absolute amount of in-band radiation is measured with four photodiode assemblies installed under angles of θ = 30, 42, 64 and 115° with respect to the target’s surface normal.
The photodiode assemblies use a multilayer mirror near normal incidence to reflect the in-band light onto the photodiode detectors. Remaining optical radiation is filtered by an EUV-transmissive Si/Zr coating on the photodiodes. Next, following the approach of [34] (and analogously to [46] and [57]) the measured in-band energy values are corrected for the respective solid angle and fitted with the monotonous smooth function

\[ f(\theta) = (\alpha - \beta) \cos(\theta/2)^\gamma + \beta, \]  

with amplitude \(\alpha\), offset \(\beta\) and power \(\gamma\). We note that this function differs from the fit function \(\sim \cos(\theta)^\gamma\) used in Schupp et al [34]. The adaption is needed to capture the emission under angles \(\theta > 90^\circ\) also in cases \(\gamma < 1\). The resulting fitted curves, using either fit function, are found to be indistinguishable over the backward hemisphere where \(\theta < 90^\circ\). The integral amount of in-band radiation over the hemisphere around the incoming laser beam is then calculated by integration of equation (1)

\[ E_{\text{IB,2\pi}} = 2\pi \int_{0}^{\pi/2} f(\theta) \sin \theta d\theta. \]  

Using this value, CE is defined as \(E_{\text{IB,2\pi}}/E_\lambda\). We further define an anisotropy factor of the in-band emission to gauge which fraction of in-band light is emitted to the backward hemisphere via \(E_{\text{IB,2\pi}}/E_{\text{IB,4\pi}}\), where \(E_{\text{IB,4\pi}}\) is obtained by changing the upper integration boundary in equation (2) to \(\pi\), hence integrating over all angles. A large anisotropy factor is favorable for industrial application as light-collecting optics typically cover the backward hemisphere.

A second measure for source performance is the spectral purity (SP), defined as the ratio of in-band energy to the total EUV energy. All SP values provided in the following are calculated from angular-resolved measurements with a 60 degree angle. A third measure, the radiation efficiency \(\eta_{\text{rad}}\) of the plasma is defined as the ratio of CE over SP following [34] and yields the total amount of EUV light emitted in the 5.5–25.5 nm wavelength band per incoming laser energy. In the current work, and in contrast to [34], \(\eta_{\text{rad}}\) is defined using the values measured at 60°, i.e. using the in-band EUV energy emitted per steradian under an angle of 60° (this value is subsequently multiplied with 2\(\pi\)), meaning \(E_{\text{IB,60°}}/E_L/\text{SP}\), instead of using CE that is defined over the entire laser-facing hemisphere. This is undertaken because the spectra and hence the SP values are expected to show strong angular dependence for expanded targets [49, 58], a dependence that is further expected to be influenced by the target diameter.

3. EUV generation using 2 \(\mu\)m light on preformed targets

In the following, the influence of target diameter, laser intensity and laser pulse duration on CE, SP, \(\eta_{\text{rad}}\), \(E_{\text{IB,2\pi}}\) and \(E_{\text{IB,2\pi}}/E_{\text{IB,4\pi}}\) are investigated. Further, the spectral emission and angular distribution of the in-band emission are discussed.

3.1. Target diameter

To investigate the influence of target size, tin targets of various sizes as produced from pre-pulse-impacted 27 \(\mu\)m-diameter droplets are irradiated with laser pulses having an intensity of \(0.6 \times 10^{11}\) W cm\(^{-2}\) and a pulse duration of 4.5 ns (downward triangles in figure 2). Data recorded using higher laser intensities and different pulse lengths are also shown but will be discussed in sections 3.2 and 3.3, respectively. Starting from an undeformed droplet target, CE has a low value of approximately 0.15% that almost linearly increases with target diameter (see figure 2(a)). At diameters of 170 \(\mu\)m and above, CE starts to plateau at a value of approximately 2.6%. This plateau sets in where the target is roughly a factor of 1.5–2 larger than the FWHM size of the beam. A similar result was observed for 1 \(\mu\)m-driven plasmas from tin coated glass spheres by Yuspeh et al [59].

An increase in CE with target diameter is expected as an enlarged target diameter increases the geometrical overlap of laser beam and target. This overlap fraction is referred to as energy-on-target (EoT, following the definition in [50] and [51]). We note that there is a near complete absorption of laser light by the efficient inverse bremsstrahlung mechanism for this wavelength laser light at the here-relevant intensities [51], where laser light geometrically overlaps with the target. For a circular spot, EoT is given by the function \(A(1 - 2^{-d_1/d_2})\), where \(d_1 = (a + b)/2\) and \(a\) and \(b\) are similar to within a few percent. The free fit factor \(A\), the amplitude of the EoT curve, is obtained from a global fit to the asymptotic CE value of all data presented in figures 2(a) and 2(e). The observed dependence of CE on target size is seen to be well approximated by the geometric overlap function (dashed line in figure 2(a)).

All CE values are calculated from angular-resolved measurements of the plasma’s in-band emission and all data points represent the mean over 300 individual laser shots. The angular dependence of the measured in-band energies (see figure 2(k)) is first fitted with equation (1) and the CE value is subsequently calculated using the integration result from equation (2). For better visibility, all curves in figure 2(k) are normalized at 0°. Equation (1) is seen to accurately describe the angular dependence of the in-band EUV emission. The increase of in-band light observed at a target diameter of 94 \(\mu\)m and under an angle of 42° is however not fully captured by the fit function and this data point may in fact be an outlier.

The reduced emission in the propagation direction of the laser at 180° with increasing target size may be caused by the one-sided heating of the expanded tin target by the laser beam. Plasma emission in this direction is shielded by the target (which is still thought to be present in liquid form during the laser pulse) and only plasma formed on the edge of the target presumably contributes to in-band emission under angles larger than 90°. The dashed line in figure 2(k) shows Lambert’s cosine law for the angular emission from a planar surface. With increasing target diameter the in-band emission starts to converge to this cos(\(\theta\)) dependence, however without fully reaching it. This might be expected because of the 3-dimensional
Figure 2. Results obtained with a 2 µm drive laser wavelength. Panels (a) and (e) depict CE; (b) and (f) SP; (c) and (g) $\eta_{\text{rad}}$; (d) and (h) anisotropy factor $E_{\text{IB,2\pi}}/E_{\text{IB,4\pi}}$, as function of target diameter, for three different intensities and laser pulse durations. SP and $\eta_{\text{rad}}$ are obtained from measurements of the spectrum and in-band energy under a 60° angle. During the intensity scans the idler beam had a slightly longer pulse duration of 4.5 ns (cf 3.7 ns during pulse duration scan) and the $1.3 \times 10^{11} \text{ W cm}^{-2}$ scan is shown in the pulse duration scan also. The dashed lines in panels (a), (c), (e), and (g) represent the results of a fit of the geometrical overlap of laser beam and target. The gray dashed lines in (b) and (f) indicate the SP values from measurements on planar-solid tin targets obtained from [37]. Also shown are normalized spectra versus (j) target size, (l) laser intensity and (n) pulse duration. The corresponding angular dependence of in-band emission, normalized at 0°, is shown in panels (k), (m) and (o). The solid lines depict fits of equation (1) to the data; the dash-dotted line in (k) indicates the $\cos(\theta)$ dependence of the Lambert cosine law.

extent of the plasma, causing departure of the emission characteristics from a Lambert-type distribution. Furthermore, emission will always exist at angles larger than 90° from the edge of the plasma unless $d_T \gg d_L$.

Next, the angular in-band distribution is quantified via an anisotropy factor, defined as the ratio of $E_{\text{IB,2\pi}}/E_{\text{IB,4\pi}}$, meaning the fraction of all in-band energy that is emitted into the backward hemisphere of the incoming laser beam, relevant for EUV lithography applications. The anisotropy factor starts at a value of 0.57 for the droplet target, where 0.5 indicates an equal split between both hemispheres (see figure 2(d)). The anisotropy factor then linearly increases with target diameter up to a value of 0.79, meaning that an ever-larger fraction of the in-band EUV is emitted into the backward hemisphere.

The in-band energy emitted in the $2\pi$ hemisphere towards the laser (obtained from multiplying the CE with the laser
pulse energy) is shown in figure 2(i). Naturally, the same trends are observed as in the case of CE. A maximum of $\sim$1 mJ of in-band EUV energy is produced (per laser shot) for this lowest intensity case.

Figure 2(j) depicts spectra from the lowest intensity case for a succession of four target diameters. For visibility and ease of comparison the spectra are normalized to their respective maximum values. Similar to previously published work, where a 2 $\mu$m laser was used to produce plasma from spherical, undisturbed droplet targets [33], all spectra show a strong emission feature at 13.5 nm originating from transitions in Sn$^{8+}$–Sn$^{14+}$ ions [6]. Transitions in these charge states further lead to the radiation observed in the 6–12 nm wavelength region [60]. With increasing target diameter, the feature at 13.5 nm widens significantly from 0.8 to 1.5 nm (FWHM). These are values between those of 1 mm-driven low-density plasmas from planar SnO$_2$ targets of 0.5–1.5 nm [47, 61] and plasmas from solid-planar tin targets of typically 2–3 nm [58]. In [34] a FWHM of 0.9 nm was reached in the case of a 1 $\mu$m-driven plasma on a tin microdroplet target. 10 $\mu$m laser-driven tin plasmas typically have a narrower 13.5-nm feature, reaching 0.6 nm (FWHM) [62]. The 2 $\mu$m-driven plasma is thus seen to produce spectra with spectral widths typically in between those produced with 1- and 10 $\mu$m laser-driven pure tin plasmas.

In contrast to the scaling of CE, SP has its maximum at the smallest target diameter. The highest value shown in figure 2(b) is 11.5% at a 90 $\mu$m diameter down from a maximum value of $\sim$14% for the case of an undeformed droplet. SP for the undisturbed droplet target for this lowest intensity case is omitted from figure 2(b) due to the low signal-to-noise ratio in the recorded spectrum. With increasing target diameter SP is observed to decrease monotonously, an effect previously observed for 1 $\mu$m beams on droplet targets [34]. Above 200 $\mu$m diameter the decrease in SP plateaus towards a value of 7.5% at a 260 $\mu$m diameter. These SP values are consistent with [37], where the SP for planar-solid tin target plasmas was measured at 7.4% (dashed line in panel (b)).

Using these SP values as input, a monotonic increase of $\eta_{\text{rad}}$ with target diameter is observed up to a value of $\sim$0.3 at a 260 $\mu$m target diameter (cf figure 2(c)). Also indicated is the dependence of EoT on target size, now with an amplitude fit value of 0.29 (dashed curve). The here measured maximum radiative efficiency at 60° is slightly lower than a value of approximately 0.4 measured for an extended solid-planar target [37]. This difference originates from the slightly higher in-band emission at 60° measured on the planar target and may be explained by the smaller beam-spot size in the planar target case that allows for the in-band emission to escape more freely. Over the entire range of target diameters, the radiative efficiency qualitatively follows the EoT trend.

At this point, it is worthwhile to consider the fact that both overall CE and $\eta_{\text{rad}}$ qualitatively follow the EoT curve, describing the increasing geometrical overlap between an enlarging target and laser beam spot. However, we also note that the SP, which serves as input for calculating $\eta_{\text{rad}}$, monotonically decreases with increasing target size. This apparent contradiction is resolved when considering the angular dependence of the plasma emission, with the increasing anisotropy factor serving to offset the decrease in SP with increasing target size (cf figures 2(b) and (d)).

### 3.2. Laser intensity

Next, target diameter scans are performed for two higher laser intensities of 1.0 and 1.3 $\times 10^{11}$ W cm$^{-2}$. The CE curves for all three laser intensities show a trend very similar to the 0.6 $\times 10^{11}$ W cm$^{-2}$ intensity case presented in section 3.1 (see figure 2(a)). For all target diameters, CE values are found to be slightly higher at higher laser intensities. The maximum CE value at large target diameters increases modestly from 2.6% to 2.9%. The angular distribution of in-band emission is observed to be independent of laser intensity within the scanned range (cf figure 2(m)). Given the constant maximum CE values, the amount of in-band radiation increases linearly with increasing laser intensity, with up to 2.3 mJ of in-band light obtained for the highest intensity case (see figure 2(i)).

In figure 2(l) normalized spectra for a target diameter of 250 $\mu$m are shown. For all spectra, the 8–25 nm region looks remarkably alike. The most prominent difference between the spectra is seen in the 5–8 nm region where the amount of radiation is observed to increase with increasing laser intensity. This emission could stem from charge states Sn$^{14+}$ (and above) as well as from an increased fraction of light being emitted from electronic states having higher excitation energies. The corresponding SP values are shown in figure 2(b). All laser intensity cases follow the same trend. The maximum SP value for the two higher intensities is 14.5% and is reached at the smallest target diameter, i.e. the undeformed droplet target. SP steadily decreases with increasing target size, and levels off at a value of up to 8% depending on intensity. Even though the differences in SP are small, we do note that optimum SP values are observed for an intermediate intensity of 1.0 $\times 10^{11}$ W cm$^{-2}$.

Given the similar scaling of CE and SP with target diameter for the three laser intensities, the radiative efficiency in figure 2(c) closely follows the 0.6 $\times 10^{11}$ W cm$^{-2}$ results, with a slightly higher value of 0.35 obtained for the highest intensity case.

No significant changes are thus observed in the scaling of emission characteristics with target size when changing laser intensity and in-band EUV emission is seen to exhibit a linear dependence on laser energy.

### 3.3. Pulse duration

Lastly, the laser pulse duration is varied from 3.7 to 7.4 ns (blue markers in figure 2) by combining signal and idler beams while delaying the signal with respect to the idler pulse. To obtain identical focal spot conditions for both beams, the beam size of the signal beam is carefully matched to that of the idler beam.
by means of a telescope. The energy of both beams is individually controlled via combinations of λ/2-plates and TFPs. Signal and idler beams are set to have equal energies. The resulting temporal pulse profile is shown in figure 1(d). Measurements are taken with 35 μm-diameter droplets, slightly larger than those used during the laser intensity scan. We note that no dependence of CE on the initial droplet diameter is observed for target size scans performed for a range of droplet diameters from 19 to 45 μm diameter as long as the target thickness is sufficient to supply tin throughout the laser pulse. As an additional data set for the laser pulse duration we add the high-intensity (1.3 × 10^11 W cm⁻²) scan from the previous section 3.2 that had slightly longer idler pulse duration of 4.6 ns due to slightly different settings of the MOPA system.

Again, CE is found to follow the same trend with increasing target diameter as described in section 3.1. A slightly higher maximum CE value of 2.9% is observed for the short and intermediate pulse durations, compared with a value of 2.6% obtained for the longest pulse duration. We note that the small observed changes in CE may lie within the systematic uncertainties of the experiment. The rather small changes in CE with pulse duration, as well as laser intensity, imply a near-linear scaling of in-band energy with laser energy. The in-band energy (figure 2(i)) indeed almost doubles when doubling the laser pulse duration, and up to 3.8 mJ of in-band energy are measured per pulse. The angular distributions of in-band EUV emission are all similar up to an angle of 64° from which point the 7.4-ns case shows increased emission. The anisotropy factor in this 7.4-ns case (see figure 2(h)) roughly follows the one of the short and medium pulse duration cases up to a target diameter of 180 μm, after which it remains roughly constant at values around 0.6. This observed difference may be attributed to an increased EUV emission volume (which increases with pulse duration), partially extending beyond the liquid disk target, which enables radiating into the forward hemisphere. Another factor contributing to this difference may be a slight tilt of the disk target due to finite tilt of the alignment of the laser to the droplet [63].

The recorded spectra, shown in figure 2(n), are remarkably similar when comparing the different laser pulse lengths. The only minor visible difference is the slightly wider main emission feature in the 7.4 ns case. SP also remains virtually independent of laser pulse duration and follows the same trend as discussed in section 3.1. We note that the small decrease in wavelength from idler to signal may contribute to the observed spectral broadening at the 7.4 ns pulse duration. However, the influence on the spectral emission is expected to be rather limited as the change in wavelength is small. Instead, we expect a larger spatial extent of the plasma at longer pulse durations, which causes larger optical depth and, hence, further spectral broadening. For the longest pulse duration case, we note that the decrease in SP with increasing target size is no longer fully compensated by increases in the anisotropy factor and this is reflected in slightly lower overall CE values.

No major changes were thus observed in the scaling of emission characteristics with target size when changing laser pulse length, besides a levelling off of the anisotropy factor for the longest pulse length. In-band EUV emission is also here seen to follow linearly the input laser energy.

4. EUV generation using 1- and 2 μm laser light

In a separate, third set of experiments, plasma is produced using the 1 μm laser beam at an intensity of 1.9(4)× 10¹¹ W cm⁻². This choice of laser intensity yields identical emission features in the 5–12 nm region compared to the 1.0(2)× 10¹¹ W cm⁻² intensity at 2 μm. Equivalent spectral features ensure a similar charge state distribution of the plasma as each feature is charge-state specific. The factor of 1.9 difference in relative intensity is in agreement with the intensity ratio of 2.1(6) observed for droplet targets [33] and 2.4(7) for planar-solid targets [37].

As shown in figure 3(a), CE is found to increase monotonically with increasing target size in the 2 μm case until the laser beam reaches full overlap with the target, as described in section 3. In line with the findings in [64] CE is virtually identical for both laser wavelength cases for small target sizes. With increasing target diameter, the 2 μm CE values exceed the ones of the 1 μm case however significantly. The 1 μm CE is found to increase in a near-linear fashion until it plateaus at a value of close to 1.8% above ~150 μm target diameter. In the case of planar-solid targets (effectively infinitely extended disk targets), very similar CE values of 1.7% were inferred from measurements performed at a representative angle of 60° for a comparable 4.8 ns pulse duration and a slightly smaller circular 66 μm-diameter (FWHM) spot [37]. In the 2 μm case, CE values measured on planar-solid targets reach up to 3.1%, only slightly higher than the here-observed values of up to 2.8%.

The angular dependence of the in-band EUV emission for the droplet target (see figure 3(g)) is very similar for both drive lasers and is consistent with previous studies where a 1 μm laser was used to drive the LPP from a droplet target [34, 43, 57]. The similarities in the angular distributions is in line with a previous study by Chen et al [65] where only minor changes in emission anisotropy were found between 1- and 10 μm-driven droplet plasmas. Similarly to section 3, the in-band emission decreases more strongly with increasing angle, in particular for the angles ≥ 90°, for the 250 μm target diameter than for the undeformed droplet target case (see figure 3(i)).

For the droplet target the anisotropy factor attains a value of 0.57, identical for both laser wavelength cases (see figure 3(d)). In both laser wavelength cases, the anisotropy factor increases linearly with increasing target diameter as discussed above in section 3.2. Uncertainties related to the slightly worse fit of the anisotropy function to the 1 μm disk-target data, which unexpectedly converges to 0 at 180°, may lead to a minor systematic overestimation of the anisotropy factor.

The in-band energy values displayed in figure 3(e) trivially follow the scaling of CE. In the 1 μm case, values of approximately 1.4 mJ per pulse are achieved while reaching approximately 1.7 mJ in the 2 μm case. The relative difference in the in-band energy values is slightly smaller than for
Figure 3. Comparison of results for drive laser beams of 1- and 2 \( \mu m \) wavelength at intensities of 1.9 and 1.0 \( \times 10^{11} \) W cm\(^{-2} \), respectively. (a) CE, (b) SP, (c) \( \eta_{\text{rad}} \), (d) anisotropy factor \( E_{\text{IB},2\nu}/E_{\text{IB},4\nu} \), and (e) \( E_{\text{IB},2\nu} \), as function of target diameter. The dashed lines in (a) and (b) indicate the CE and SP values from planar-solid tin targets, respectively [37]. The spectral emission of plasmas for a target diameter of (f) 27 \( \mu m \) (droplet target) and (h) 250 \( \mu m \) (disk target) are shown normalized to their respective peak intensities. The 1 \( \mu m \) spectrum shown in (h) is normalized to laser energy with respect to the 2 \( \mu m \) one. The at 0\(^\circ\) normalized angular dependencies of the in-band EUV emission, corresponding to the spectra shown in (f) and (h), are shown in (g) and (i), respectively. Solid lines depict fits of equation (1) to the data.

For undeformed droplet targets, the spectra for the 2 \( \mu m \) case show a much narrower main emission feature and, relative to the 13.5-nm peak, less out-of-band radiation is emitted in the 2 \( \mu m \) case (see figure 3(f)). These observations are consistent with earlier results [33, 34]. With increasing target diameter the differences in the spectral emission between the two drive laser wavelengths become even more pronounced. In the 2 \( \mu m \) case, the main emission feature simply broadens with target diameter (see figure 2(h)), in line with expectations from an associated increase in optical depth [32]. In the 1 \( \mu m \) case, the shape of the main emission feature changes drastically due to strong self-absorption, causing the emission maximum to shift to shorter wavelength. These absorption effects become even stronger for increased laser pulse duration, redistributing even more light into other energy channels (see appendix). This ‘missing’ emission in the main feature in the 1 \( \mu m \) case is qualitatively well explained by absorption of in-band radiation from a hotter plasma zone by a colder less emissive plasma zone [37, 66].

SP is found to decrease monotonously with increasing target diameter for both wavelength cases (see figure 3(b)). In the 1 \( \mu m \) case, the SP for small target diameters is on the order of 10\%, and is observed to decrease more rapidly than its 2 \( \mu m \) counterpart down to 4.5\% at a 250 \( \mu m \) diameter. This value is consistent with the marginally lower SP value of 4\% obtained from measurements on planar-solid tin targets which may be taken as the asymptotic value of SP towards infinite target size [37]. SP in the 2 \( \mu m \) case levels off at a higher value of about 8\%, in part explaining the higher CE values observed using this drive laser wavelength.

Radiative efficiency, measured at an angle of 60\(^\circ\), follows a very similar trend in both wavelength cases (see panel (c)) with a larger amplitude in the 1 \( \mu m \) case due to the significantly lower SP values in this laser wavelength case.

No major differences between the anisotropy factors are observed. Comparing the two drive laser wavelength cases, the differences in CE are largely attributable to the decrease in SP. This link between CE and SP further supports the findings...
of Behnke et al [37], where experiments on solid tin targets demonstrated that plasmas driven by 1 µm laser light exhibit strong EUV self-absorption which is absent in the 2 µm spectra. This makes 2 µm-driven plasmas the more efficient emitter of in-band EUV radiation. We note that conversion efficiencies of up to 3% can in fact be achieved for the 1 µm drive laser case for a homogeneous heating of undeformed droplet targets with several 10-ns-long, spatially flatter-shaped laser pulses [34]. Thus, on one hand, the current limitations to CE for the 1 µm drive laser case for extended disk targets may be eased using alternate target and illumination designs. On the other hand, even larger CE values for the 2 µm drive laser case may be obtained from optimally shaped targets homogeneously heated by a long, flatter laser pulse.

5. Conclusions

We have studied plasmas produced from laser pre-pulse preformed liquid tin disk targets with diameters ranging 30–300 µm using 1- and 2 µm drive laser systems. For the 2 µm driver, the conversion efficiency of laser energy to EUV radiation closely follows the fraction of the laser energy absorbed by the tin target and CE values of up to 3% are obtained for the largest targets. Conversion efficiency (CE), spectral purity (SP), radiative efficiency (\(\eta_{rad}\)), and spectral emission are found to be nearly independent of laser intensity and laser pulse duration in the here-studied parameter range. Consequently, a linear increase of in-band radiation towards the backward hemisphere with laser energy is observed when increasing either parameter and further scaling of in-band output per tin target with laser intensity and pulse duration may be possible at little to no cost regarding CE.

Direct comparison of the emission characteristics of 1- and 2 µm-driven plasmas reveals significantly lower CE values for the 1 µm driver under the current experimental conditions when using extended disk targets. The lower 1 µm CE is explained by the particularly strong self-absorption of the emitted EUV radiation in the 1 µm-driven plasma. Comparing here measured CE values of 3% to ones of current state-of-the-art EUV light sources driven by 10 µm CO₂ gas lasers (CE ≈ 6%), CE values of the 2 µm driven plasma are lower by a factor of two. However, comparing overall source efficiency of converting electrical energy to in-band photons, the 2 µm driven source may already exhibit higher overall efficiencies because of the expected significantly higher wall plug efficiency of 2 µm solid state laser technology compared to 10 µm CO₂ gas laser technology. Further, more improvements in terms of CE may be obtainable by homogeneous heating of suitably shaped tin targets with longer laser pulses leading to full evaporation of the then truly ‘mass-limited’ tin targets. Such future studies should include research on the influence of laser pulse duration, intensity and laser wavelength on any possible fast ionic or liquid debris that may harm nearby optics elements in possible future industrial EUV light sources based on 2 µm-laser-driven tin plasmas.

Data availability statement

The data that support the findings of this study are available upon reasonable request from the authors.

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Appendix. EUV generation using longer pulses of 1- and 2 µm wavelength—long pulse duration

In addition to the comparison between 1- and 2 µm-driven plasmas for the short-pulse case in section 4, more data is obtained using longer 1 µm pulses that mimic the temporal profile of the 7.4 ns case in section 3.3. The parameters of CE, SP, \(\eta_{rad}\), \(E_{IB,2\pi}/E_{IB,4\pi}\) and \(E_{IB,2\pi}\) show similar trends compared to the short-pulse data in section 3.3.

The only significant change in comparison with the short-pulse data is observed in the spectral emission of the two drive-laser wavelength cases for disk-targets in figure 4(h). Here, the spectral emission of plasmas produced with the 1 µm laser beam show even stronger self-absorption of emission at and around 13.5 nm. This stronger absorption manifests itself in slightly lower SP values. The slight deviation in the trend of \(\eta_{rad}\) above 160 µm target diameter in the 2 µm case was already discussed in the main text.

In summary, good spectral performance of the plasma and high CE values are continued to be observed when increasing laser pulse duration of the 2 µm driver. In contrast, increasing the pulse duration of the 1 µm-wavelength driver, self-absorption effects increase significantly and lead to an even larger unwanted redistributing of in-band radiation into other energy channels than in the short-pulse case.
Figure 4. Comparison of results for drive laser beams of 1- and 2 µm wavelength at intensities of $2.3 \times 10^{11}$ W cm$^{-2}$, respectively, but for a longer pulse duration of 7.4 ns. (a) CE, (b) SP, (c) $\eta_{\text{rad}}$, (d) anisotropy factor $E_{\text{IB}}/E_{\text{IB}}$, and (e) $E_{\text{IB}}$, as function of target diameter. The dashed lines in (a) and (b) indicate the CE and SP values from planar-solid tin targets, respectively [37]. The spectral emission of plasmas for a target diameter of (f) 35 µm (droplet target) and (h) 250 µm (disk target) are shown normalized to their respective peak intensities. The 1 µm spectrum shown in (h) is normalized to laser energy with respect to the 2 µm one. The at $0^\circ$ normalized angular dependencies of the in-band EUV emission, corresponding to the spectra shown in (f) and (h), are shown in (g) and (i), respectively. Solid lines depict fits of equation (1) to the data.

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